



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al. Art Unit : Unknown
Serial No. : 10/647,539 Examiner : Unknown
Filed : August 26, 2003
Title : SEMICONDUCTOR THIN FILM AND ITS MANUFACTURING METHOD
AND SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Supplemental to an information disclosure statement filed with the application on August 26, 2003, Applicants submit the reference listed on the attached form PTO-1449.

This statement is being filed before the receipt of a first Office action on the merits.

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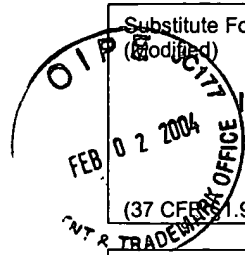
Respectfully submitted,

Date: February 2, 2004



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| Substitute Form PTO-1449 (Modified) | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 07977-126004 | Application No. 10/647,539 |
| Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR 1.98(b)) | | Applicant Shunpei Yamazaki et al. | |
| | | Filing Date August 26, 2003 | Group Art Unit |

U.S. Patent Documents

| Examiner Initial | Desig. ID | Document Number | Publication Date | Patentee | Class | Subclass | Filing Date If Appropriate |
|------------------|-----------|-----------------|------------------|----------|-------|----------|----------------------------|
| | AA | | | | | | |
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Foreign Patent Documents or Published Foreign Patent Applications

| Examiner Initial | Desig. ID | Document Number | Publication Date | Country or Patent Office | Class | Subclass | Translation | |
|------------------|-----------|-----------------|------------------|--------------------------|-------|----------|-------------|----|
| | | | | | | | Yes | No |
| | AL | 08-255916 | 10/01/1996 | JAPAN | | | Full | |
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Other Documents (include Author, Title, Date, and Place of Publication)

| Examiner Initial | Desig. ID | Document |
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| Examiner Signature | Date Considered |
| EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |